



Norman Ruhnke (Autor)

A deep ultraviolet laser light source by frequency doubling of GaN based external cavity diode laser radiation

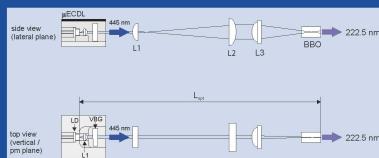


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Forschungsberichte aus dem

Ferdinand-Braun-Institut,
Leibniz-Institut
für Höchstfrequenztechnik

A deep ultraviolet laser light source
by frequency doubling of GaN based
external cavity diode laser radiation



Innovationen mit Mikrowellen & Licht

Norman Ruhnke

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